Attorney Docket No. 04209/LH

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Y. AONO et al

Serial No. : Not yet assigned

Filed : Herewith

For : TOTAL INTERNAL

REFLECTION FLUORE-

SCENCE MICROSCOPE

Art Unit : Examiner :

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450, Alexandria, VA 22313-1450

SIR:

Submitted herewith are copies of the publications identified on the attached Patent Office form PTO/SB/08A.

Japanese Patent No. 3093145 is identified at page 3, line 9 of the present specification. The English abstract for Japanese Patent No. 3093145 is identified as "09-159922" which is the 18-month publication of the Japanese application which matured into Japanese Patent No. 3093145.

Japanese No. 2001-013413 is identified at page 4, lines 5-6 of the specification.

It is respectfully requested that the publications submitted herewith be considered and made of record. /

Respectfully submixted,

Leonard Holtz Reg. No. 22,9

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1 Unique citation designation number. 2 See kinds of U.S. Patent Documents. 3 Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 4 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 5 Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. 6 Place a check here if English translation is attached.

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